



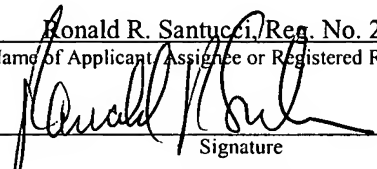
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Tetsuo YAMADA, et al.
Serial No. : 10/518,704
For : THIN FILM PIEZOELECTRIC RESONATOR, THIN
FILM PIEZOELECTRIC DEVICE, AND
MANUFACTURING METHOD THEREOF (As Amended)
Filing Date : December 17, 2004
Examiner : Mark Osborne Budd
Group Art Unit : 2834
Confirmation No. : 5674

745 Fifth Avenue
New York, NY 10151
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I hereby certify that this correspondence is being deposited with
the United States Postal Service as first class mail in an envelope
addressed to: **Mail Stop Amendment, Commissioner for
Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on April
30 2007.**

Ronald R. Santucci, Reg. No. 28,988
(Name of Applicant, Assignee or Registered Representative)

Signature
April 30 2007
Date of Signature

AMENDMENT UNDER 37 C.F.R. 121

AF
Mail Stop ~~Amendment~~
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action dated March 1, 2007, setting a three-month
period for response ending June 1, 2007, Applicants respectfully request that the application be
further amended as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 16 of this paper.